

Appl. No. 10/810,309  
Amdt. Dated November 29, 2006  
Reply to Final Office Action of September 19, 2006

Attorney Docket No. 81716.0122  
Customer No. 26021

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:  
Isamu AKASAKI et al.  
Serial No.: 10/810,309  
Confirmation No.: 8006  
Filed: March 26, 2004  
For: SEMICONDUCTOR APPARATUS,  
METHOD FOR GROWING NITRIDE  
SEMICONDUCTOR AND METHOD  
FOR PRODUCING  
SEMICONDUCTOR APPARATUS

Art Unit: 2814

Examiner: Thao X. Le

I hereby certify that this correspondence is  
being transmitted via facsimile to:  
(571) 273-8300.

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450, on

November 29, 2006

Date of Deposit

Diane Zynn

Name

Signature

11/29/06

Date

AMENDMENT UNDER 37 C.F.R. § 1.116

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action dated September 19, 2006, please  
amend the above-referenced application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on  
page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.